

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/625,889	<b>Applicant(s)/Patent under Reexamination</b> KLEIN, ROBERT C.
	<b>Examiner</b> Robert E. Fennema	<b>Art Unit</b> 2183

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner